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Bib Data Sheet

CONFIRMATION NO. 6839

SERIAL NUMBER 10/017,396	FILING DATE 12/18/2001 RULE	CLASS 428	GROUP ART UNIT 1771	ATTORNEY DOCKET NO. PF-2088DIV	
APPLICANTS Kazuhiko Endo, Tokyo, JAPAN;					
** CONTINUING DATA ***** THIS APPLICATION IS A DIV OF 09/093,193 06/08/1998 - <i>Roche 428/307.3</i>					
** FOREIGN APPLICATIONS ***** JAPAN 09-150762 06/09/1997					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/26/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> 12/18/01 Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 38 <i>16</i>	INDEPENDENT CLAIMS <i>2 3</i>
ADDRESS 080466					
TITLE <i>Method of Forming A</i> Silica insulation film with a reduced dielectric constant and method of forming the same					
FILING FEE RECEIVED 1064	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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